

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Steven M. Zuniga, et al. Art Unit : 1763
Serial No. : 09/848,830 Examiner : S. MacArthur
Filed : May 3, 2001
Title : A CARRIER HEAD WITH A MULTILAYER RETAINING RING FOR
CHEMICAL MECHANICAL POLISHING

Commissioner for Patents
Washington, D.C. 20231

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RESPONSE

In response to the action mailed May 9, 2002, please amend the application as follows:

In the specification:

Please amend the paragraph beginning at page 1, line 2, as follows:

A¹⁰ This application is a continuation application of and claims priority to U.S. Patent
Application Serial No. 09/090,679, filed June 3, 1998, issued as U.S. Patent No. 6,251,215.

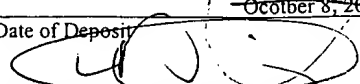
In the claims:

Please amend claim 1, 3-5 and 13 as follows:

1. (Amended) A carrier head for a chemical mechanical polishing apparatus,
comprising:
a rigid base;
A₁ a substrate mounting surface that is vertically movable relative to the base; and
a retaining ring to maintain a substrate beneath the mounting surface during polishing, the
retaining ring including
a substantially annular lower portion having a bottom surface for contacting a
polishing pad during polishing, wherein the lower portion is made of a plastic, and

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11/8/02